



BENHA UNIVERSITY
FACULTY OF ENGINEERING (SHOUBRA)
ELECTRONICS AND COMMUNICATIONS ENGINEERING



CCE 201
Solid State Electronic Devices
(2022 - 2023) term 231

Lecture 4: Current Flow in Semiconductors.

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Outlines



Drift Current.

Diffusion Current.

Summary.

Drift Current:

- Q: What happens when an electrical field (E) is applied to a semiconductor crystal ?

A: When an electric field is applied, the carriers are accelerated by the force due to the electric field (Newton's law). Holes are accelerated **in the direction** of E, free electrons are **repelled**.

- How is the velocity of these holes defined?

$$\underbrace{\mu_p = \text{hole mobility}}_{E = \text{electric field}} \\ v_{p\text{-drift}} = \mu_p E$$

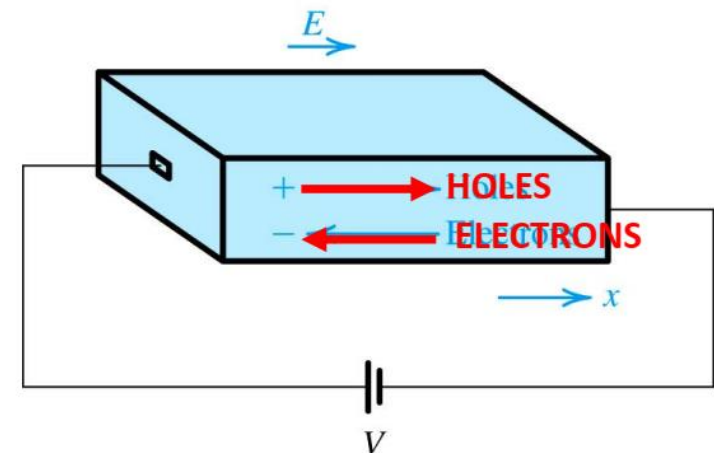
$$\underbrace{\mu_n = \text{electron mobility}}_{E = \text{electric field}} \\ v_{n\text{-drift}} = -\mu_n E$$

Note: that electrons move with velocity **2.5 times higher** than holes

$$\mu_p \text{ (cm}^2\text{/Vs)} = 480 \text{ for silicon}$$

$$\mu_n \text{ (cm}^2\text{/Vs)} = 1350 \text{ for silicon}$$

- An electric field **E** established in a bar of silicon causes the **holes to drift in the direction of E** and the **free electrons to drift in the opposite direction**. Both the hole and electron **drift currents are in the direction of E**.



Drift Current:

- The **net drift motion** of the ensemble of carriers produces an **electric current**.
- Electric current **density** J_{drift} , by definition, is **the net charge crossing per unit area of an arbitrary plane per unit time**.

$$J_p = qp v_{p,\text{drift}} = qp \mu_p E$$

- A similar expression for the electric current due to electrons may be derived.

$$J_n = qn v_{n,\text{drift}} = (-q)n(-\mu_n E) = qn \mu_n E$$

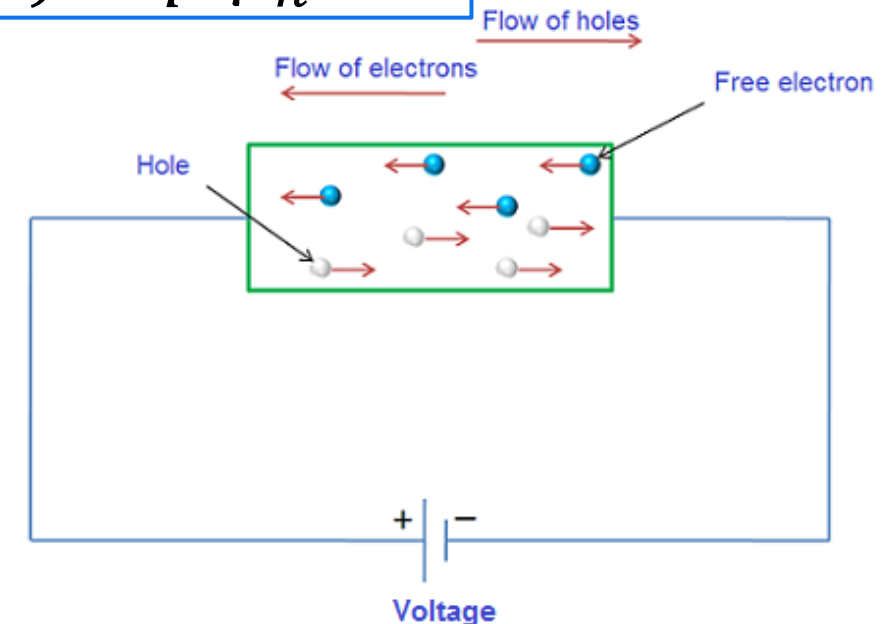
- Electric current:

$$I_p = AJ_p = Aqp \mu_p E$$

$$I_n = AJ_n = Aqn \mu_n E$$

- The total drift current density defined as:

$$\begin{aligned} J_{\text{drift}} &= J_p + J_n = qp \mu_p E + qn \mu_n E \\ &= q (p \mu_p + n \mu_n) E = \sigma E \end{aligned}$$



Drift Current:

- conductivity (σ) : relates current density (J) and electrical field (E)

$$J = \sigma E$$

$$\sigma = q (p\mu_p + n\mu_n)$$

- resistivity (ρ) : relates current density (J) and electrical field (E).

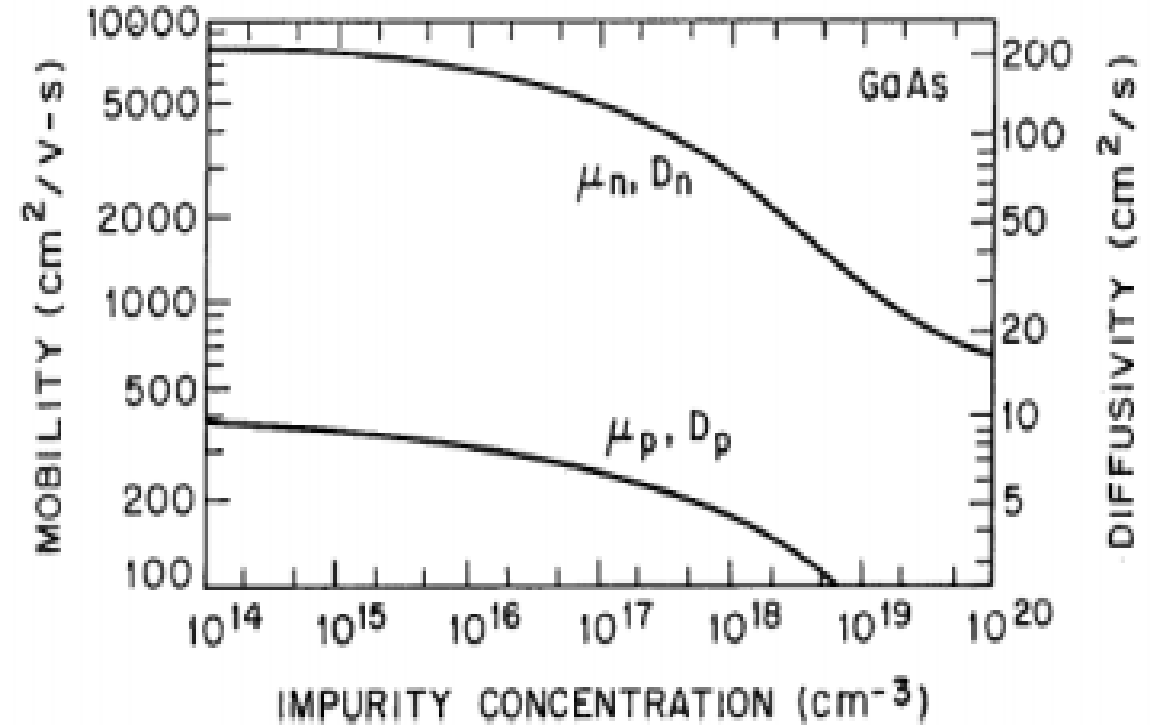
$$\rho = \frac{1}{q (p\mu_p + n\mu_n)}$$

Drift Current:

Parameter	SI units	Standard units
Current density	A/m^2	A/cm^2
Electric field	V/m	V/cm
Resistivity	$\Omega\text{-m}$	$\Omega\text{-cm}$
Conductivity	S	$\Omega^{-1}\text{cm}^{-1}$
	(Siemens = $\Omega^{-1}\text{m}^{-1}$)	
Mobility	$(m/s)/(V/m)=m^2/Vs$	cm^2/Vs
carrier concentration	m^{-3}	cm^{-3}
Charge	C	C

Doping dependence of mobility

Doping reduces carrier mobility



Drift Current:

Q(a): Find the resistivity of intrinsic silicon using following values – $\mu_n = 1350 \text{ cm}^2/\text{Vs}$, $\mu_p = 480 \text{ cm}^2/\text{Vs}$, $n_i = 1.5 \times 10^{10} / \text{cm}^3$.

(a) For intrinsic silicon,

$$p = n = n_i = 1.5 \times 10^{10} / \text{cm}^3$$

$$\begin{aligned} \rho &= \frac{1}{q(p\mu_p + n\mu_n)} = \frac{1}{1.6 \times 10^{-19} (1.5 \times 10^{10} \times 480 + 1.5 \times 10^{10} \times 1350)} \\ &= 2.28 \times 10^5 \Omega \cdot \text{cm} \end{aligned}$$

Q(b): Find the resistivity of p -type silicon with $N_A = 10^{16} / \text{cm}^2$ and using the following values – $\mu_n = 1110 \text{ cm}^2/\text{Vs}$, $\mu_p = 400 \text{ cm}^2/\text{Vs}$, $n_i = 1.5 \times 10^{10} / \text{cm}^3$

(b) For the p -type silicon

$$p_p \approx N_A = 10^{16} / \text{cm}^3$$

$$n_p \approx \frac{n_i^2}{N_A} = \frac{(1.5 \times 10^{10})^2}{10^{16}} = 2.25 \times 10^4 / \text{cm}^3$$

$$\begin{aligned} \rho &= \frac{1}{q(p\mu_p + n\mu_n)} = \frac{1}{1.6 \times 10^{-19} (10^{16} \times 400 + 2.25 \times 10^4 \times 1110)} \\ &= 1.56 \Omega \cdot \text{cm} \end{aligned}$$

Drift Current:

A uniform bar of n -type silicon of $2\ \mu\text{m}$ length has a voltage of $1\ \text{V}$ applied across it. If $N_D = 10^6/\text{cm}^3$ and $\mu_n = 1350\text{cm}^2/\text{V}\cdot\text{s}$, find (a) the electron drift velocity, (b) the time it takes an electron to cross the $2\text{-}\mu\text{m}$ length, (c) the drift-current density, and (d) the drift current in the case the silicon bar has a cross sectional area of $0.25\ \mu\text{m}^2$.

a. $v_{n\text{-drift}} = -\mu_n E$

Here negative sign indicates that electrons move in a direction opposite to E

We use

$$v_{n\text{-drift}} = -\mu_n E$$

$$= 1350 \times \frac{1}{2 \times 10^{-4}} \quad \because 1\ \mu\text{m} = 10^{-4}\ \text{cm}$$

$$= 6.75 \times 10^6\ \text{cm/s} = 6.75 \times 10^4\ \text{m/s}$$

b. Time taken to cross $2\ \mu\text{m}$ length

$$= \frac{\text{distance}}{v_{\text{drift}}} = \frac{2 \times 10^{-6}}{6.75 \times 10^4} = 30\ \text{ps}$$

c. The current density J_n is given by

$$J_n = qn\mu_n E$$

$$= 1.6 \times 10^{-19} \times 10^{16} \times 1350 \times \frac{1}{2 \times 10^{-4}} = 1.08 \times 10^4\ \text{A/cm}^2$$

d. Drift current $I_n = J_n A$

$$I_n = 0.25 \times 10^{-8} \times 1.08 \times 10^4 = 27\ \mu\text{A}$$

Outlines



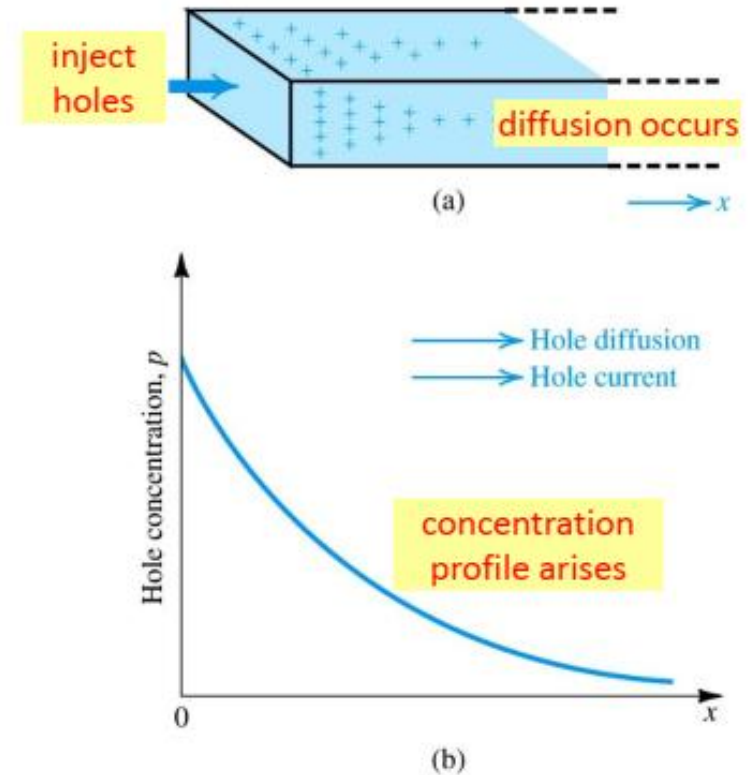
Drift Current.

Diffusion Current.

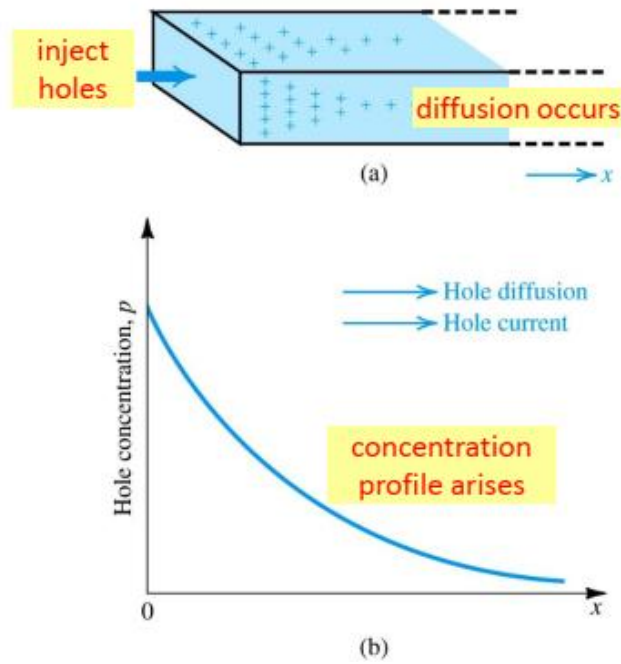
Summary.

Diffusion Current

- There is another type of current in semiconductors that arises due to the **diffusion of carriers**. Diffusion is also a consequence of random thermal motion of carriers. But the exact source of diffusion is the **non-uniform spatial distribution of carriers**.
- We have assumed so far that the carrier concentration distribution is **uniform** everywhere inside the semiconductor. This **may not always be true**. For example, the impurity distribution inside a semiconductor may vary due to processing conditions.
- Let us now analyze the consequence of **non-uniform distribution of carriers**.
- However, when carrier concentration is **non-uniform**, more number of carriers move out of **the higher carrier concentration region** than the number of carriers that move into it. As a result, there is a net motion of carriers from **the higher concentration region to a lower concentration region**. Thermal agitation causes the carriers to spread in such a way as to equalize the distribution. This motion of carriers is known as the **diffusion**.

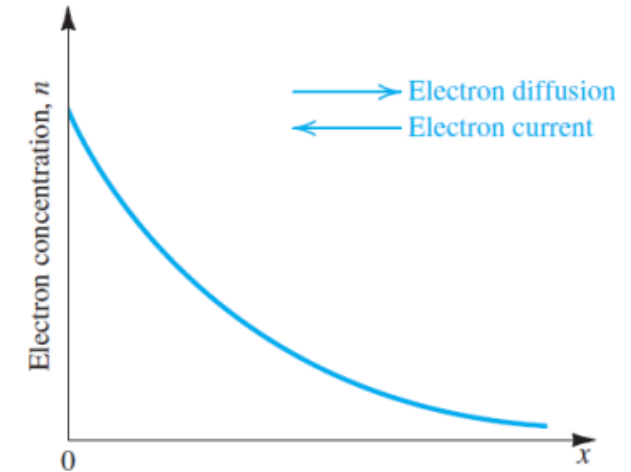


Diffusion Current



J_p = current flow density attributed to holes
 q = magnitude of the electron charge
 D_p = diffusion constant of holes ($12\text{cm}^2/\text{s}$ for silicon)
 $p(x)$ = hole concentration at point x
 dp/dx = gradient of hole concentration

$$\text{hole diffusion current density: } J_p = -qD_p \frac{dp(x)}{dx}$$



$$\text{electron diffusion current density: } J_n = +qD_n \frac{dn(x)}{dx}$$

J_n = current flow density attributed to free electrons
 D_n = diffusion constant of electrons ($35\text{cm}^2/\text{s}$ for silicon)
 $n(x)$ = free electron concentration at point x
 dn/dx = gradient of free electron concentration

Observe that a **negative** (dn/dx) gives rise to a **negative current**, a result of the **convention** that the **positive direction of current** is taken to be that of the **flow of positive charge** (and opposite to that of the flow of negative charge).

Diffusion Current

Consider a bar of silicon in which a hole concentration $\mathbf{p}(x)$ described below is established.

Q(a): Find the hole-current density J_p at $x=0$.

Q(b): Find current I_p .

- Note the following parameters: $p_0 = 10^{16}/\text{cm}^3$, $L_p = 1\ \mu\text{m}$, $A = 100\ \mu\text{m}^2$

$$\mathbf{p}(x) = p_0 e^{-x/L_p}$$

$$J_p = -qD_p \frac{dp(x)}{dx} = -qD_p \frac{d}{dx} \left[p_0 e^{-x/L_p} \right]$$

$$J_p(0) = q \frac{D_p}{L_p} p_0 = 192 \text{ A/cm}^2$$

$$I_p = J_p \times A = 192 \ \mu\text{A}$$

Relationship Between D and μ

➤ the relationship between diffusion constant (D) and mobility (μ) is defined by thermal voltage (v_T).

➤ known as **Einstein Relationship**:
$$\frac{D_n}{\mu_n} = \frac{D_p}{\mu_p} = V_T$$

➤ Thermal voltage:
$$V_T = \frac{KT}{q}$$
 at T = 300K, $V_T = 25.9\text{mV}$

Summary :

$$J_{p,drift} = qp\mu_p E$$

$$I_p = Aqp\mu_p E$$

$$J_{n,drift} = qn\mu_n E$$

$$I_n = Aqn\mu_n E$$

$$J_{drift} = J_{p,drift} + J_{n,drift} = q(p\mu_p + n\mu_n) E = \sigma E$$

$$\sigma = q(p\mu_p + n\mu_n)$$

$$J_{p,diff} = -qD_p \frac{dp(x)}{dx}$$

$$I_p = -AqD_p \frac{dp(x)}{dx}$$

$$\rho = \frac{1}{q(p\mu_p + n\mu_n)}$$

$$J_{n,diff} = qD_n \frac{dn(x)}{dx}$$

$$I_n = AqD_n \frac{dn(x)}{dx}$$

$$\frac{D_n}{\mu_n} = \frac{D_p}{\mu_p} = V_T$$

$$J_{diff} = J_{p,diff} + J_{n,diff} = -qD_p \frac{dp(x)}{dx} + qD_n \frac{dn(x)}{dx}$$

$$V_T = \frac{KT}{q}$$

$$J_{Total} = J_{drift} + J_{diff} = [q(p\mu_p + n\mu_n) E] + \left[-qD_p \frac{dp(x)}{dx} + qD_n \frac{dn(x)}{dx} \right]$$



END OF LECTURE

BEST WISHES